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Practitioner's Docket No. 13621-43433

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hoover, Brian G.
Application No.: 10/625,769 Group No.: 3738
Filed: July 23, 2003 Examiner:
For: CORNEAL IMPLANTS PRODUCED BY IRRADIATION OF POLYMER FILMS

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M. W.

Matthew S. Wermager
Reg. No. 53760
Customer No. 26257
Rodey Dickason Sloan Akin & Robb, PA
PO Box 1888
Albuquerque, NM 87103-1888
505-768-7239

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Substitute for form 1449A/PTO

(Use as many sheets as necessary)

Sheet

1

of

1

Application Number

10/625,769

Filing Date

07/23/2003

First Named Inventor

Brian G. Hoover

Art Unit

3738

Examiner Name

Attorney Docket Number

13621-43433

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

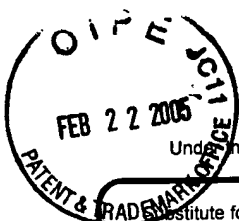
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/625,769
				Filing Date	07/23/2003
				First Named Inventor	Brian G. Hoover
				Art Unit	3738
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	13621-43433

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T ²
	A	WOLF, STANLEY PH.D. AND TAUBER, RICHARD N. PH.D., "SILICON PROCESSING FOR THE VLSI ERA, Volume 1: Process Technology," Book, 1st ed., Lattice Press (Sunset Beach, California), p. 430-437, (February 8, 1986).		
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	E	VALIEV, K.A.; VELIKOV, L.V.; DUSHENKOV, S.D., "Pore formation in PMMA during x-ray exposure," Journal, Sov. Phys. Tech. Phys. (USSR), Vol. 32 (No. 7), p. 862-863, (February 8, 1988).		
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	I	VIRK, H.S., et al., "Effects on insulators of swift-heavy-ion irradiation: ion-track technology," Journal, J. Phys. D: Appl. Phys., IOP Publishing Ltd. (UK), Vol. 31, p. 3139-3145, (1998).		
	J	YASHAR, Alyson G., "Artificial iris device may reduce glare," Magazine, Opthamology Times, Advanstar Communications, Inc., (September 15, 2000)		

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